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SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING

THE SAME

Suggested Representative Figure:

Fig. 1

Legal Representative:

Attorney or Agent:

Jeffrey L. Costellia

Registration Number:

35483

**Customer Number Correspondence Address:** 

22204

\*22204\*

Foreign Priority:

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Assignee (Publish): Semiconductor Energy Laboratory Co., Ltd., 398, Hase

Atsugi-shi 243-0036 Kanagawa-ken JP

**INVENTOR(s):** 

Primary Citizenship:

JΡ

Given Name:

Osamu

Family Name:

NAKAMURA

Residence City:

Atsugi-shi

Residence Country:

JΡ

M Address:

 $\tilde{\Gamma}_{ij}^{(i)}$ 

Hern

c/o Semiconductor Energy Laboratory Co., Ltd., 398, Hase

Atsugi-shi Kanagawa-ken, 243-0036 JP

Primary Citizenship:

JΡ

Given Name:

Masayuki

Family Name:

KAJIWARA

Residence City:

Atsugi-shi

Residence Country:

JP

Address:

c/o Semiconductor Energy Laboratory Co., Ltd., 398 Hase

Atsugi-shi Kanagawa-ken, 243-0036 JP

Primary Citizenship:

JP

Given Name:

Junichi

Family Name:

KOEZUKA

Residence City: Residence Country: Atsugi-shi JP

Address:

c/o Semiconductor Energy Laboratory Co., Ltd., 398, Hase





## Atsugi-shi Kanagawa-ken, 243-0036 JP

Primary Citizenship:

JΡ

Given Name:

Shunpei

Family Name:

YAMAZAKI

Residence City:

Atsugi-shi

Residence Country:

JΡ

Address:

c/o Semiconductor Energy Laboratory Co., Ltd., 398, Hase

Atsugi-shi Kanagawa-ken, 243-0036 JP

Primary Citizenship:

JΡ

Given Name:

Hideaki

Family Name:

**KUWABARA** 

Residence City:

Atsugi-shi

Residence Country:

JP

Address:

c/o Semiconductor Energy Laboratory Co., Ltd., 398, Hase

Atsugi-shi Kanagawa-ken, 243-0036 JP